

Docket No. 216-028B

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: KATSIR, D. ET AL.
Serial No. : not known
Filed : June 29, 2001
For : METHOD FOR PRODUCING HIGH SURFACE
: AREA FOIL ELECTRODES
Art Unit : 1775
Examiner : Young, B.

New York, New York 10036
June 28, 2001

Commissioner for Patents
Washington D.C. 20231

PRELIMINARY AMENDMENT

Kindly amend the subject application as follows:

IN THE SPECIFICATION

Kindly add the following paragraph at page 1, line 1:

--This application is a continuation of Serial No. 09/334,664,
filed March 3, 1998.--

IN THE CLAIMS:

Kindly cancel claims 1-28

Kindly amend 29 and 34 to read as follows:

29. (Amended) A non-anodized article of manufacture having a fractal surficial structure which includes both valve metal and an oxide thereof, the valve metal being selected from the


group consisting of aluminum, titanium, tantalum, niobium, zirconium, silicon, thorium, cadmium and tungsten.

34. (Amended) An electrode comprising:
an electrically conductive substrate; and
a discontinuous non-anodized layer, of an oxide of a first valve metal, on a surface of said substrate.

REMARKS

This Amendment is being filed to amend the claims to point out certain preferred embodiments of the invention.

Respectfully submitted,


James V. Costigan
Reg. No. 25,669

MAILING ADDRESS:
HEDMAN & COSTIGAN, P.C.
1185 Avenue of the Americas
New York, NY 10036-2601
(212) 302-8989

Marked up copy of claims which shows deleted subject matter in brackets and added subject matter underlined:

29. (Amended) A[n] non-anodized article of manufacture [comprising a valve metal] having a fractal[-like] surficial structure which includes both valve metal and an oxide thereof, the valve metal being selected from the group consisting of aluminum, titanium, tantalum, niobium, zirconium, silicon, thorium, cadmium and tungsten.

34. (Amended) An electrode comprising:
[(a)] an electrically conductive substrate; and
[(b)] a discontinuous non-anodized layer, of an oxide of a first valve metal, on a surface of said substrate.